



1762

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
RICHARD J. MARKLE  
ROBERT J. CHONG

Group Art Unit: 1762

Examiner: Unknown

Serial No.: 09/911,264

Atty. Dkt. No.: 2000.082800/TT4490

Filed: July 23, 2001

For: PROCESS CONTROL BASED UPON  
WEIGHT OR MASS MEASUREMENTS,  
AND SYSTEMS FOR ACCOMPLISHING  
SAME

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JAN 04 2002  
TC 1700

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

CERTIFICATE OF MAILING 37 C.F.R. 1.8	
I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date below:	
October 19, 2001 Date	 Signature

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents required by 37 C.F.R. § 1.98(a)(2) are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. §§ 1.97(g),(h), this Information Disclosure Statement is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b).

The present Information Disclosure Statement is being filed prior to the receipt of a first Official Action reflecting an examination on the merits, and hence is believed to be timely filed in accordance with 37 C.F.R § 1.97(b). No fees are believed to be due in connection with the filing of this Information Disclosure Statement, however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be deemed necessary for any reason relating to these materials, the Assistant Commissioner is hereby authorized to deduct said fees from Williams, Morgan & Amerson, P.C., Deposit Account No. 50-0786/2000.082800.

Applicants respectfully request that the listed documents be made of record in the present case.

Date: October 19, 2001

Respectfully submitted,

A handwritten signature in black ink, appearing to read "J. Mike Amerson", is written over a horizontal line.

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Form PTO-1449 (modified)

List of Patents and Publications for Applicant's

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty. Docket No.  
2000.082800/TT4490Serial No.  
09/911,264Applicant  
Richard J. Markle and Robert J. ChongFiling Date:  
July 23, 2001Group:  
1762U.S. Patent Documents  
See Page 1Foreign Patent Documents  
See Page 1Other Art  
See Page 1

## U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1						
	A2						
	A3						
	A4						
	A5						

## Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						
	B2						
	B3						

## Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	Christel <i>et al.</i> , "Single-Crystal Silicon Pressure Sensors with 500 × Overpressure Protection," <i>Sensors and Actuators</i> , A21-A23:84-88, 1990
	C2	Guckel, "Surface Micromachined Pressure Transducers," <i>Sensors and Actuators</i> , A28:133-46, 1991
	C3	Ko <i>et al.</i> , "A High Sensitivity Integrated-Circuit Capacitive Pressure Transducer," <i>IEEE Transactions on Electron Devices</i> , ED-29:48-56, 1982
	C4	Lee and Wise, "A Batch-Fabricated Silicon Capacitive Pressure Transducer with Low Temperature Sensitivity," <i>IEEE Transactions on Electron Devices</i> , ED-29:42-48, 1982
	C5	Mallon <i>et al.</i> , "Low-Pressure Sensors Employing Bossed Diaphragms and Precision Etch-Stopping," <i>Sensors and Actuators</i> , A21-A23:89-95, 1990
	C6	Sander <i>et al.</i> , "A Monolithic Capacitive Pressure Sensor with Pulse-Period Output," <i>IEEE Transactions on Electron Devices</i> , ED-27:927-30, 1980

EXAMINER:

DATE CONSIDERED:

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